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By: Patricia Muir

Patricia Muir

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Hiroshi OKUMURA

Serial No.: 10/615,670

Filed: July 8, 2003

Title: **METHOD OF FORMING SEMICONDUCTOR THIN-FILM  
AND LASER APPARATUS USED THEREFORE**

Examiner: Samuel M. Heinrich

Group Art Unit: 1725

Confirmation No.: 9827

Attorney Docket No.: 100806-00215 (NECA 20.494)

October 26, 2005

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

S I R :

In response to the Office Action mailed on August 1, 2005, the period for responding thereto having been set to expire after November 1, 2005, please amend the above-captioned application as follows: